Imale

AF/1746

| AMENDMENT TRANSMITTAL LETTER (Large Entity)  Applicant(s): Qingyuan et al.   |   |                          |   |                            |     | Docket No.<br>00-SM5-408 |  |  |
|--|---|--------------------------|---|----------------------------|-----|--------------------------|--|--|
| Serial No.<br>09/864,003   |   | Filing Date May 23, 2001 | 2 9 2004  | Examiner<br>dexander Marko | off |                          | Group Art Unit<br>1746                           |  |
| Invention: PLASMA PROCESS FOR REMOVING PROPERTY AND RESIDUES FROM SUBSTRATES |   |                          |   |                            |     |                          |  |  |
| TO THE COMMISSIONER FOR PATENTS:   |   |                          |   |                            |     |                          |  |  |
| Transmitted here   | with is an amend  | dment in the above-ide   | entified appli  | cation.                    |     |                          | •  |  |
| The fee has been   | calculated and  | is transmitted as show   | vn below.   |                            |     |                          | -  |  |
|  |   | CLAIM                    | S AS AMENI  | DED                        |     |                          |  |  |
|  | CLAIMS REMAI  |                          |   | JMBER EXTRA                | RA  | NTE                      | ADDITIONAL                                       |  |
| TOTAL CLAIMS   | AFTER AMENDA<br>20  | PREV. PAID - 22          | = CL  | AIMS PRESENT 0             | x : | \$18.00                  | FEE \$0.00                                       |  |
| INDEP. CLAIMS  | 3   | - 4                      | =   |                            |     | \$84.00                  | \$0.00   |  |
| Multiple Dependent Claims (check if applicable)                              |   |                          |   |                            |     |                          | \$0.00   |  |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.00                               |   |                          |   |                            |     |                          |  |  |
| Please ch A check i The Direct communi                                       | targe Deposit Act the amount of stor is hereby au cation or credit additional filing the patent application of the signature |                          | the filing feetyment of the eposit Accourt C.F.R. 1.16 der 37 CFR | nt No. 06-1130             | 004 | ent and fee              | is being deposited on S. Postal Service as first |  |
| Telephone No. (8   |   |                          |   |                            |     | . 1.8 and                | is addressed to the                              |  |

Typed or Printed Name of Person Mailing Correspondence



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| Applicant:  | Qingyuan et al.  | ) Group Art Unit: 1746           |
|-------------|--|----------------------------------|
| Serial No.: | 09/864,003   | )                                |
| Filed:      | May 23, 2001   | ) ) Examiner: Markoff, Alexander |
| For:        | PLASMA PROCESS FOR REMOVING<br>POLYMER AND RESIDUES FROM<br>SUBSTRATES | )<br>)<br>)                      |

## AMENDMENT C

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

This amendment is submitted in response to the Final Office Action dated February 2, 2004. Please amend the Application as follows: